

RG-2000AL (RG-3000AL) FULLY-AUTO SHEET RESISTANCE/RESISTIVITY MEASUREMENT

RG-2000AL(RG-3000AL)



- Fully automatic system with one cassette station
- Multi-point, Contact Type using 4-point probe method
- Widest measuring range and High accuracy
- User programmable measurement pattern
- Tester self-test function
- Thickness, edge, temperature correction for silicon wafer
- Film thickness conversion function from sheet resistance
- Measure Range:
 - ✓ Resistivity ($\Omega \cdot \text{cm}$): 0.1m to 1M
 - ✓ Sheet Resistance (Ω/sq): 1m to 10M
- Sample Size (\varnothing): 6", 8" or 12"

APPLICABLE MATERIALS

- Semiconductor and Solar-cell materials (Silicon, Polysilicon, SiC etc)
- Others: On Request

